

7/25/2001

PATENT

1046 U.S. PRO
09/916847
07/26/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : John E. Peterson, et al.

Attorney Docket No. : IL-10786

Serial No. :

Art Unit:

Filed :

Examiner:

For : Reduction of Damage Initiation Density in Fused Silica Optics
via UV Laser Conditioning

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

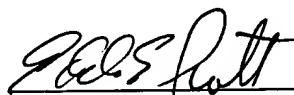
Dear Sir:

Forwarded herewith is an Information Disclosure Statement, Form-1449, in the above-identified application. Copies of the cited references are enclosed: 11 U.S. Patents and 1 Other Disclosure.

The above-mentioned disclosures, which are not admitted as prior art, are identified on the enclosed Form 1449.

Respectfully submitted,

Dated: July 25, 2001



Eddie E. Scott
Attorney for Applicant
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Enclosures: As noted above

